1. Refer to MIT BRACHING 85-081024 for schematic connections and wire assignments.
2. Fabricate I/A W NASA SPEC NHB300-400.
4. Perform contact retention test on all contacts per MSFC-STD-76, record results in.awt.
5. Electrical tests are to be performed I/A NHB300-400. Record results in awt.
6. Torque hardware to 38 in-lb, spotweld with F/N 19.
7. Item is static sensitive, handle I/A W kit procedure 99-01003.
8. Mask for conformal coat as indicated. Mask all wires from connectors.
9. Vacuum bake all connectors at 85°C for 72 hours prior to hitting and installation.
10. Conformal coat using F/N 36.
    -Dure at 85°C, ambient pressure for 8 hours.
    -Remove masking and masking residue prior to bake.
    -Vacuum bake at 85°C, 10^-4 torr for 24 hours.

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